## UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Hiroshi YOSHIDA

Group Art Unit: 2818

Application Number: 10/501,080

Examiner: Chuong A. Luu

Filed: December 14, 2004

Confirmation Number: 3317

For:

**METHOD** FOR **GETTERING**  **TRANSITION METAL** 

IMPURITIES IN SILICON CRYSTAL

Attorney Docket Number:

042440

Customer Number:

38834

## RESPONSE

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 June 22, 2006

Sir:

This paper is filed in response to the Office Action dated March 27, 2006.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.